Attorney Docket: 29936/39764
Inventor: Cha Deok Dong
Title: "Method of Forming Device Isolation
Film in Semiconductor Device"

Sheet $1\ \text{of}\ 2$

FIG. 1

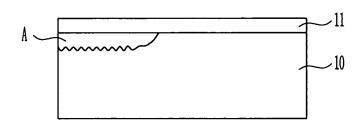


FIG. 2

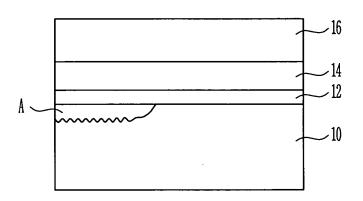
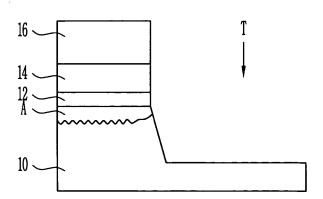


FIG. 3



Attorney Docket: 29936/39764
Inventor: Cha Deok Dong
Title: "Method of Forming Device Isolation
Film in Semiconductor Device"

Sheet 2 of 2

FIG. 4

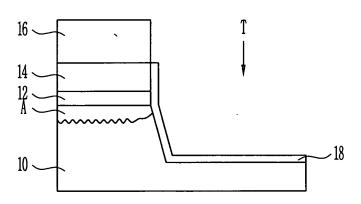


FIG. 5

